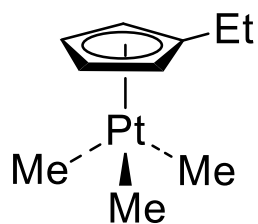


Catalog # 78-1375 (Trimethyl)ethylcyclopentadienylplatinum(IV) (99.999%-Pt) PURATREM



Technical Notes

1. Organometallic precursor for chemical vapour deposition (CVD) of Pt films [1-3]

References:

1. *Chem. Vap. Deposition*, **2003**, 9, 321.
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